

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re Patent Application of:	)	Group Art Unit: 1753
	)	
Takeshi Nogami et al.	)	Confirmation No.: 3159
	)	
Application No. 10/775,935	)	
	)	
Filed: February 10, 2004	)	
	)	
For: SEMICONDUCTOR MANUFACTURING	)	Examiner: Luan V. Van
APPARATUS AND METHOD FOR	)	
MANUFACTURING SEMICONDUCTOR	)	
DEVICES	)	

MAIL STOP AMENDMENT  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

**RESPONSE TO AUGUST 10, 2006 OFFICE ACTION**

Dear Sir:

This Amendment is submitted in response to the Office Action mailed August 10, 2006. Applicants respectfully request amendment of the patent application, and reconsideration and allowance of the pending claims.